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**Complete If Known**

Application Number	10/553,600
Filing Date	October 18, 2005
First Named Inventor	Haruhiko KOMORIYA
Art Unit	1712
Examiner Name	To Be Assigned
Attorney Docket Number	038788.56807US

**U.S. PATENT DOCUMENTS**

Examiner Initials'	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>3</sup> (if known)			
/N.C./	AA	US- 3,036,091	05-22-1962	England	

**FOREIGN PATENT DOCUMENTS**

Examiner Initials'	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>2</sup>
		Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)				
/N.C./	AB	WO 2004/014960 A2	02-19-2004	E. I. DuPont De Nemours and Company		
/N.C./	AC	WO 02/36533 A1	05-10-2002	Daiicel Chemical Industries, Ltd.		ABS
/N.C./	AD	JP 2003-55362 A	02-26-2003	Showa Denko Kabushiki Kalsha		
/N.C./	AE	JP 2003-2883 A	01-08-2003	Shin-Etsu Chemical Co., Ltd.		

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
/N.C./	AF	DAMMEL et al., "New Resin Systems for 157nm Lithography", Journal of Photopolymer Science and Technology, 2001, Vol. 14, No. 4, pages 603 - 611.	
/N.C./	AG	FEDYNYSHYN et al., "Fluoroaromatic Resists for 157-nm Lithography", Journal of Photopolymer Science and Technology, 2002, Vol. 15, No. 4, pages 655 - 666.	
/N.C./	AH	International Search Report dated May 25, 2004 (Two (2) pages).	

Examiner Signature	/Nizal Chandrakumar/	Date Considered	12/20/2007
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